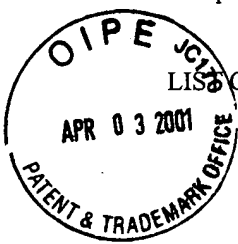


U.S. Department of Commerce, Patent and Trademark Office 					Docket No.: 5403/CMP/RKK		Serial No.: 09/771,086	
LIST OF RELEVANT ART CITED BY APPLICANT (Use several sheets if necessary)					Applicants: Alexander Lerner et al.			
					Filing Date: 1/27/01		Group: unknown	

U.S. Patent Documents							
*Examiner Initial	Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate	
MS	AA	4,326,619	Garnett	193	37		
MS	AB	4,557,506	Hanks et al.	285	39		
MS	AC	5,036,625	Gosis	451	286		
MS	AD	5,527,209	Volodarsky et al.	451	388		
MS	AE	5,707,186	Gobell et al.	409	136		
MS	AF	5,749,584	Skinner et al.	415	173.5		
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MS	AH	5,901,643	Bornhorst	100	282		
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	AJ						
	AK						

Foreign Patent Documents							Translation	
Document Number	Date	Country	Class	Subclass	Yes	No		

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)		
MS	AR	Patent Abstracts of Japan, Application No. 54063613, Dated 04.12.80,
	AS	
	AT	

Examiner: <i>Mark Ansel</i>	Date Considered: <i>5/27/03</i>
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.